

Docket No.: VRO-02001
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Stanley W. Stone

Confirmation Number: 9153

Application No.: 10/687,023

Art Unit: 3652

Filed: October 16, 2003

Examiner: C. A. Fox

For: WAFER HANDLER METHOD AND SYSTEM

TRANSMITTAL OF DRAWING CORRECTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Submitted herewith is a corrected drawings for filing in the above-identified Patent application.

The Examiner objected to the drawings for reasons stated in the Notice of Allowability (Paper No. PTOL-37) dated January 5, 2007. Specifically, the Examiner objected to FIG. 1 in that the dashing of lines for element 18 was not complete. The enclosed new FIG. 1 corrects the dashing of lines for element 18.

Favorable consideration of the enclosed drawing is respectfully requested.

Dated: April 3, 2007

Respectfully submitted,

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